



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kenji NISHI

Group Art Unit: 2877

Application No.: 09/782,062

Examiner: G. STOCK JR.

Filed: February 14, 2001

Docket No.: 108601

For: EXPOSURE METHOD, EXPOSURE APPARATUS, AND METHOD OF  
PRODUCING DEVICE

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the January 12, 2006 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**